## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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Application No. 09/857,912

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Application Numb Docket Number (Optional) 113197-010 INFORMATION DISCLOSURE CITATION Applicant(s) Iijima, Y., et al. (Use several sheets if necessary) Filing Date Group Art Unit June 11, 2001 Unknown U.S. PATENT DOCUMENTS FILING DATE EXAMINER CLASS SUBCLASS DATE NAME REF DOCUMENT NUMBER IF APPROPRIATE INITIAL FOREIGN PATENT DOCUMENTS Translation CLASS SUBCLASS COUNTRY DATE REF DOCUMENT NUMBER YES NO 4-30-98 **PCT** WO98/17846 9-2-98 10-231122 Japan 10-21-98 EP 0 872 579 A1 Europe 2-26-99 Japan 11-53967 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Ichinose, A., et al., "Deposition of Y203 buffer layers on biaxially-textured metal substrates," Physica C Superconductivity, Vol. 302 (1998) No. 1, June 10, 1998, pp. 51-56. DATE CONSIDERED **EXAMINER** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Patent and Trademark Office \* U.S. DEPARTMENT OF COMMERCE P09A/REV04

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